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## \*BIBDATASHEET\*

CONFIRMATION NO. 5220

Bib Data Sheet

SERIAL NUMBER 10/695,479	FILING DATE 10/28/2003  RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 856063.754
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\*\* CONTINUING DATA \*\*\*\*\*  
 NONE *PC*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 NONE *PC*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 01/29/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY ITALY	SHEETS DRAWING 7	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 3
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Verified and Acknowledged  
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 38106  
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TITLE  
 Single electron transistor manufacturing method by electro-migration of metallic nanoclusters

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		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )